



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tetsuhiro Iwai et al.
Serial No.: 10/621,497 Art Unit: 1724 ✓
Filing Date: July 17, 2003
Title: "PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD"
Docket No.: 35908

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir/Madam:

In accordance with Rule 56, applicants are aware of the publications listed in the
International Search Report (copy enclosed) and in the enclosed copy of Patent Office Form
1449. A copy of each of the publications is enclosed herewith.

Respectfully submitted,
PEARNE & GORDON LLP

By: 
Jeffrey J. Sopko, Reg. No. 27676

1801 East 9th Street
Suite 1200
Cleveland, Ohio 44114-3108

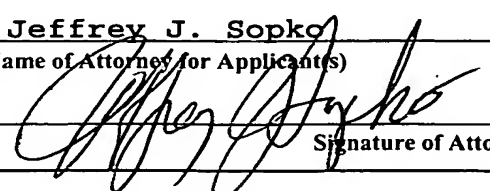
(216) 579-1700

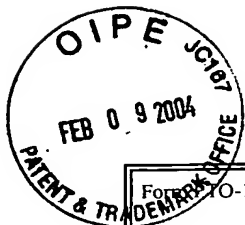
February 6, 2004

I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
addressed to: Commissioner of Patents, P.O. Box 1450,
Alexandria, Va. 22313-1450 on the date indicated below.

Jeffrey J. Sopko
Name of Attorney for Applicant(s)

02/06/2004
Date


Signature of Attorney



Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 35908	SERIAL NO. 10/621,497
INFORMATION DISCLOSURE CITATION BY APPLICANT (USE SEVERAL SHEETS IF NECESSARY)		APPLICANT: Tetsuhiro Iwai et al.	
		FILING DATE: July 17, 2003	GROUP ART UNIT: 1724

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A	5,792,376	08/1998	Kanai et al.			
	B	6,254,683 B1	07/2001	Matsuda et la.			
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						
	K						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	L						
	M						
	N						
	P						
	Q						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	R	
	S	
	T	

Examiner:	Date Considered
-----------	-----------------

***Examiner:** Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.